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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Takashi IZUTA

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Serial No. : 10/806,844

Art Unit: 1763

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Confirmation No. 2467

For : SUBSTRATE TREATING METHOD AND APPARATUS

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

**STATUS INQUIRY LETTER**

Sir:

We filed the above application with the U.S. Patent and Trademark Office on March 22, 2004. As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully submitted,

James A. Finder

Registration No. 30,173

OSTROLENK, FABER, GERB & SOFFEN, LLP

1180 Avenue of the Americas

New York, New York 10036-8403

Telephone: (212) 382-0700

JAF:lf